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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Robert P. Meagley et al.

Serial No.: 10/666,019

Filed: September 17, 2003

For: Quantum Efficient Photoacid
Generators for Photolithographic
Processes

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Art Unit: 1752

Examiner: Amanda C. Walke

Docket: ITL.1015US
P16702

Assignee: Intel Corporation

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

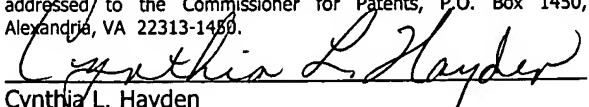
REPLY TO PAPER NO. 12202005

Sir:

In response to the office action mailed December 27, 2005, please amend the above-referenced patent application as follows:

Date of Deposit: February 21, 2006

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Cynthia L. Hayden